

APPLICANT'S ART CITATION  (Use several sheets if necessary)	Application		OGFS File No. P/4309-64
	Applicant Miroslav KOSTKA et al.		
	Filing Date Herewith	Group Art Unit	

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
/	US-5,719,360	2/1998	STONE et al.			
/	US-4,838,385	6/1989	EKHOLM			
US-						
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## FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/	WO 02 14198	2/2002	PCT			n/a	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/	PATENT ABSTRACTS OF JAPAN, vol. 017, no. 343 (M-1436), 29 June 1993 & JP 05 043142 A (Fujitsu Ltd), 23 February 1993 *Abstract*.
/	PATENT ABSTRACTS OF JAPAN, vol. 018, no. 245 (M-1603), 11 May 1994 & JP 06 032544 A (Toshiba Corp), 8 February 1994 *Abstract*.

Examiner

Date Considered

3/28/04

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